



Roots pumps

For all low and medium vacuum applications

Roots pumps



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Roots pumps













For all low and medium vacuum applications

The OktaLine series Roots pumps can be perfectly tailored to customer-specific requirements by different pumping speeds and versions. This type of pump needs a backing pump both suited to the application and designed for the gas stream.

The high-precision production technology makes it possible to achieve very high compression values, which in turn allows for maximum pumping speed at very low gas exit temperatures. Pfeiffer Vacuum Roots pumps offer low operating costs at high uptime, since electrical power and (depending on the process) a gaseous purge medium (e.g. air) are all that they require. A high cost water-cooling unit is not required. The magnetic coupled version makes leaks at the shaft feedthrough an issue of the past.

Used in combination with other Roots pumps or appropriate backing pumps, Roots pumps can be adapted perfectly to any application. Pfeiffer Vacuum as the leading supplier of vacuum solutions has more than 50 years of experience in the design of customer-specific solutions.

- Large pumping speed range from 145 to 27,400 m³/h
- Long life due to robust, compact design
- Short pumpdown time by high compression ratio and overflow valve
- Maintenance free at high operating safety and maximum availability due to the optional magnetic coupling
- Low operating costs because of air cooling and optional magnetic coupling
- A cooling water unit is not required
- Pumps available in stainless steel versions upon request
- Energie efficient, frequency converter suitable standard motors





Overview of series and applications

Analytics

Semiconductor

Coating

Industry

R&D

= recommended	Electron microscopy Leak detection	Mass spectrometry	Surface analysis	Residual gas analysis	Lithography	Physical Vapor Deposition (PVD)	Plasma etching	Implantation – Source	Implantation – Beamline	Inspection	MRE (Molecular Ream Enitexy.)	Note (Wolecular Bearn Epitaxy) Load-locks, transfer chambers, handling system	וחו	LED / OLED	Hard disk coating	Filotovoltaics Glass coating (DVD)	CD / DVD / Blu-ray production (PVD)	Optical coating (PVD)	Wear protection (PVD, CVD)	Web coating	Wedical technology	Floation beam wolding	Isolation vacuums	Lamp and tube manufacturing	Heat treatment	Vacuum drying	Vacuum furnaces	Nuclear research	Fusion technology	Particle accelerators	Space simulation	Cryogenic research	Elementary particle physics	Nanotechnology
Roots pumps Convection-cooled – OktaLine																																		
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Okta 500					H	٠	H					٠	Н		-			Е	H						ā				H		Е		Н	
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Gas-circulation-cooled - Oktal	.ine G	i																																
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Explosion-protected – OktaLine	ATEX																																	
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Okta 1000 ATEX																																		
Okta 2000 ATEX																																		1
Okta 4000 ATEX																																		

Overview of series

- Convection-cooled OktaLine
- Gas-circulation-cooled OktaLine G
- Explosion-protected OktaLine ATEX (in accordance with Directive 94/9/EC)
- Magnetic coupling as an option of all models

The integrated overflow valve is standard in all convection-cooled pumps. This makes it possible to switch the pump on at atmospheric pressure. The pump is thus automatically protected from thermal overload. The gain in additional pumping speed allows for shorter cycle times in load-lock applications and time-critical processes. Monitoring with fault-prone pressure switches and slow start up with cost-intensive frequency converters is no longer needed.

Typical applications:

- Glass and foil coating
- Plasma etching
- PVD and CVD
- Vacuum metallurgy
- Space simulation
- Vacuum drying / freeze drying
- Steel degassing / secondary metallurgy
- Electron beam welding

Advantages of magnetic coupling

All pump models of the OktaLine series can optionally be driven by means of a permanent-magnetic coupling with can. The static seal prevents a bidirectional exchange of process gas and the ambient atmosphere. These pumps are permanently hermetically sealed.

The magnetic coupling implicates further advantages: Maintenance oil changes as they become mandatory for pumps with driveshaft feedthrough are no longer necessary. Downtime and service costs will be reduced.

Integrated magnet coupling O-ring Inner magnet "Vacuum" Wacuum" Outer magnet Outer magnet



Convection-cooled – OktaLine

Convection-cooled **OktaLine Roots pumps** for all low and medium vacuum applications

The pumping speeds of convection-cooled Roots pumps range from 145 to 27,400 m³/ h. They can easily be combined and used in low and medium vacuum applications. Typical uses include industrial applications, coating, the semiconductor industry and research & development, or in chemical and process technology applications.

The gear box and bearings in our Roots pumps are separated from the gas pumping chamber. The contactless operating principle of the Roots pistons allows for technically dry operations.

A further advantage: due to convection cooling, installation and operating costs are significantly lower than for water-cooled pumps. The OktaLine can therefore be used universally.

The design concept for our proven Roots pumps was expanded to include magnetic couplings. These hermetically sealed pumps in the OktaLine M series mean that critical gases such as helium can be pumped without any problems and operating costs are minimized as the system works without a shaft feedthrough.

- Complete line of Roots pumps offers optimum flexibility and maximium process suitability
- Broad range of pumping speeds: 145 to 27,400 m³/h
- Rugged, compact design
- Fast evacuation due to high compression ratio and overflow valve
- Maintenance free at maximum reliability and highest uptime thanks to magnetic coupling
- Low operating costs thanks to air cooling and magnetic coupling
- No thermal overload because of integral overflow valve
- Long service intervals and simple on-site maintenance
- On-site service worldwide



Applications

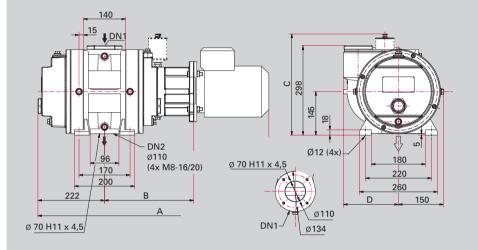
- Metallurgy
- Simulation chambers
- Packaging industry
- Freeze/vacuum-drying
- Thin-film technologyElectron beam welding
- Load-locks
- Chemistry and process technology
 Industrial leak detection systems
- Steel degassing



Convection-cooled – OktaLine

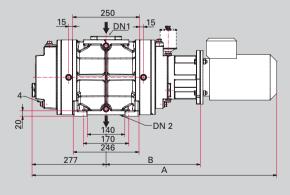
Dimensions

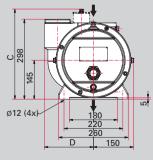
Okta 250



	Okta 250 standard	Okta 250 without motor	Okta 250 M
А	769 mm	-	799 mm
В	297 mm	297 mm	327 mm
С	337 mm	337 mm	298 mm
D	183 mm	183 mm	183 mm
Conne	ections		
DN 1	DN 63 ISO-F	DN 63 ISO-F	DN 63 ISO-F
DN 2	DN 63 ISO-F	DN 63 ISO-F	DN 63 ISO-F

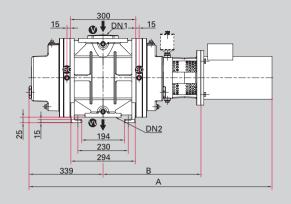
Okta 500

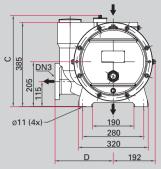




Okta 500 standard	Okta 500 without motor	Okta 500 M
915 mm	-	950 mm
352 mm	352 mm	382 mm
337 mm	337 mm	298 mm
183 mm	183 mm	183 mm
ctions		
DN 100 ISO-F	DN 100 ISO-F	DN 100 ISO-F
DN 100 ISO-F	DN 100 ISO-F	DN 100 ISO-F
	915 mm 352 mm 337 mm 183 mm ections DN 100 ISO-F	standard without motor 915 mm - 352 mm 352 mm 337 mm 337 mm 183 mm 183 mm ections DN 100 ISO-F DN 100 ISO-F DN 100 ISO-F

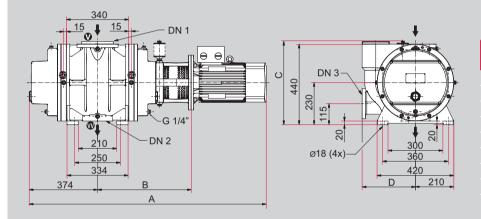
Okta 1000





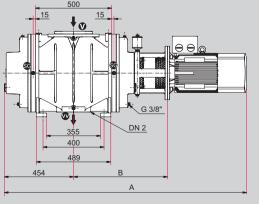
	Okta 1000 standard	Okta 1000 without motor	Okta 1000 M
Α	1112 mm	-	1125 mm
В	448 mm	448 mm	461 mm
С	418 mm	418 mm	402 mm
D	266 mm	266 mm	266 mm
Conne	ections		
DN 1	DN 160 ISO-F	DN 160 ISO-F	DN 160 ISO-F
DN 2	DN 100 ISO-F	DN 100 ISO-F	DN 100 ISO-F
DN 3	DN 100 ISO-F	DN 100 ISO-F	DN 100 ISO-F

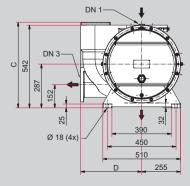
Okta 2000



	Okta 2000 standard	Okta 2000 without motor	Okta 2000 M
А	1297 mm	-	1317 mm
В	513 mm	513 mm	532 mm
С	458 mm	458 mm	458 mm
D	292 mm	292 mm	292 mm
Conne	ections		
DN 1	DN 160 ISO-F	DN 160 ISO-F	DN 160 ISO-F
DN 2	DN 100 ISO-F	DN 100 ISO-F	DN 100 ISO-F
DN 3	DN 100 ISO-F	DN 100 ISO-F	DN 100 ISO-F

Okta 4000





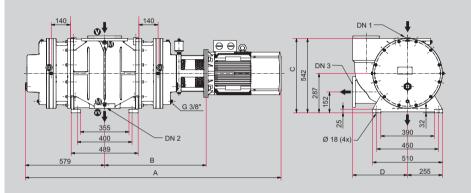
	Okta 4000 standard	Okta 4000 without motor	Okta 4000 M
А	1589 mm	-	1651 mm
В	616 mm	616 mm	678 mm
С	560 mm	560 mm	560 mm
D	400 mm	400 mm	400 mm
Conne	ctions		
DN 1	DN 250 ISO-F/ DN 250 PN 16	DN 250 ISO-F/ DN 250 PN 16	DN 250 ISO-F/ DN 250 PN 16
DN 2	DN 160 ISO-F/ DN 150 PN 16	DN 160 ISO-F/ DN 150 PN 16	DN 160 ISO-F/ DN 150 PN 16
DN 3	DN 160 ISO-F/ DN 150 PN 16	DN 160 ISO-F/ DN 150 PN 16	DN 160 ISO-F/ DN 150 PN 16



Convection-cooled – OktaLine

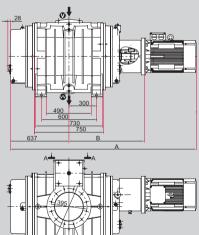
Dimensions

Okta 6000



	Okta 6000 standard	Okta 6000 without motor	Okta 6000 M
Α	1867 mm	-	1930 mm
В	741 mm	741 mm	803 mm
С	560 mm	560 mm	510 mm
D	400 mm	400 mm	390 mm
Conne	ections		
DN 1	DN 250 ISO-F/	DN 250 ISO-F/	DN 250 ISO-F/
DIVI	DN 250 PN 16	DN 250 PN 16	DN 250 PN 16
DN 2	DN 160 ISO-F/	DN 160 ISO-F/	DN 160 ISO-F/
DIN Z	DN 150 PN 16	DN 150 PN 16	DN 150 PN 16
DN 3	DN 160 ISO-F/	DN 160 ISO-F/	DN 160 ISO-F/
טוע ס	DN 150 PN 16	DN 150 PN 16	DN 150 PN 16

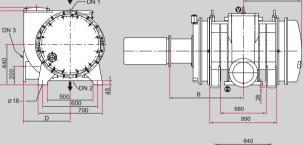


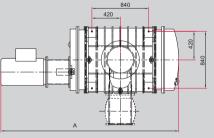


	Okta 8000 standard	Okta 8000 without motor
А	2160 mm	-
В	791 mm	791 mm
С	845 mm	845 mm
D	510 mm	510 mm
Conne	ctions	
DN 1	DN 320 ISO-F	DN 320 ISO-F
DN 2	DN 320 ISO-F	DN 320 ISO-F
DN 3	DN 250 ISO-F	DN 250 ISO-F

-M12 (12x) 18 mm tief/depth

Okta 18000

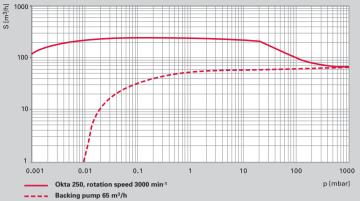




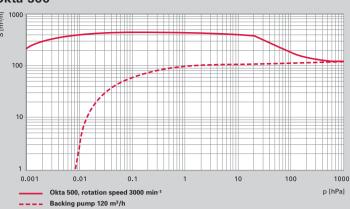
	Okta 18000 standard	Okta 18000 without motor
А	2789 mm	-
В	1090 mm	1090 mm
С	1099 mm	1099 mm
D	960 mm	960 mm
Conne	ections	
DN 1	DN 400 PN 10	DN 400 PN 10
DN 2	DN 400 PN 10	DN 400 PN 10
DN 3	DN 320 ISO-F	DN 320 ISO-F

Pumping speed

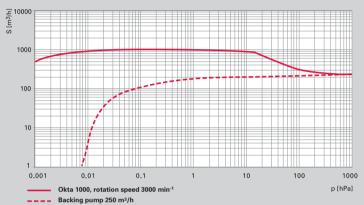




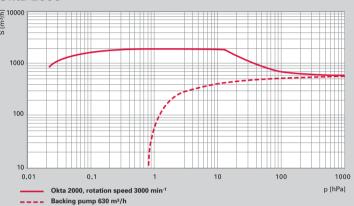
Okta 500



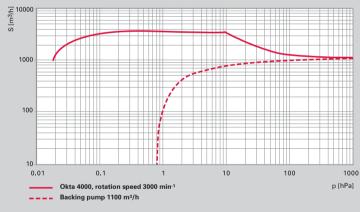
Okta 1000



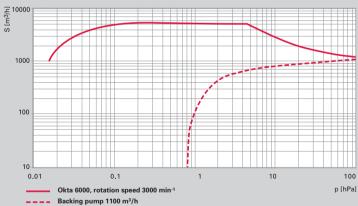
Okta 2000



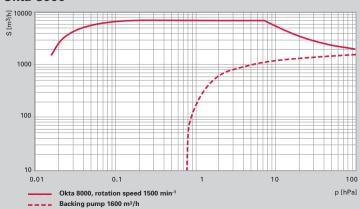
Okta 4000



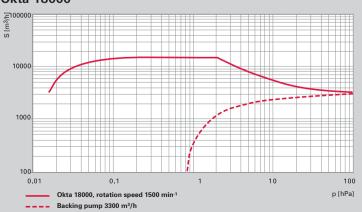
Okta 6000



Okta 8000



Okta 18000





Convection-cooled – OktaLine

Technical data

Pump type	Okta 250	Okta 500	Okta 1000
Flange (out)	DN 63 ISO-F	DN 100 ISO-F	DN 100 ISO-F
Flange (in)	DN 63 ISO-F	DN 100 ISO-F	DN 160 ISO-F
Operating fluid ¹⁾	P3	P3	P3
Operating fluid filling	1.5 I	1.5 I	2.9
Differential pressure at the overflow valve ²⁾	75 hPa	75 hPa	45 hPa
Rotation speed max.	4500 min ⁻¹	4500 min ⁻¹	4500 min ⁻¹
Rotation speed min.	1500 min ⁻¹	1500 min ⁻¹	1500 min ⁻¹
Emission sound pressure level (EN ISO 2151) at intake pressure10 hPa	75 dB (A)	75 dB (A)	75 dB (A)
Emission sound pressure level (EN ISO 2151) at intake pressure1 hPa	70 dB (A)	70 dB (A)	72 dB (A)
Weight: with motor	95 kg	132 kg	240 kg
Weight: without motor	85 kg	115 kg	215 kg
Weight: with magnet coupling	122 kg	145 kg	265 kg
Cooling method, standard	Luft	Air	Air
Leak rate: standard	1 · 10 ⁻³ Pa m ³ /s	1 · 10 ⁻³ Pa m ³ /s	1 · 10 ⁻³ Pa m ³ /s
Leak rate: with magnet coupling	1 · 10 ⁻⁶ Pa m ³ /s	1 · 10 ⁻⁶ Pa m ³ /s	1 · 10 ⁻⁶ Pa m ³ /s
Motor protection	3TF	3TF	3TF
Nominal rotation speed at 50 Hz	3000 min-1	3000 min ⁻¹	3000 min ⁻¹
Nominal rotation speed at 60 Hz	3600 min-1	3600 min ⁻¹	3600 min ⁻¹
Rated power 50 Hz	0.75 kW	1.5 kW	3.0 kW
Rated power 60 Hz	0.90 kW	1.8 kW	3.5 kW
Nominal pumping speed	145–440 m ³ /h	280-840 m ³ /h	590-1775 m ³ /h
Nominal pumping speed at 50 Hz	290 m ³ /h	560 m ³ /h	1180 m³/h
Nominal pumping speed at 60 Hz	350 m ³ /h	670 m³/h	1420 m³/h
Mains requirement: voltage 50 Hz	230/400 V	230/400 V	230/400 V
Mains requirement: voltage 60 Hz	265/460 V	265/460 V	265/460 V
Protection category	IP 55	IP 55	IP 55
Ambient temperature	5-40 °C	5-40 °C	5-40 °C
Order number			
Okta (Standard)	PP W21 000	PP W31 000	PP W41 000
Okta without motor	PP W21 001	PP W31 001	PP W41 001
Okta M	PP W22 000	PP W32 000	PP W42 000

Splinter shield PK 300 010 -X PP 030 149 AX PP 031 114 -X

¹⁾ Additional equipment and motor voltages available upon request.

²⁾ The differential pressure at the overflow valve is based on a nominal speed of 60 Hz;

for higher speeds or pressure differentials please contact the Pfeiffer Vacuum sales department.

kta 2000	Okta 4000	Okta 6000	Okta 8000	Okta 18000
NI 100 ICO F	DN 160 ISO-F/	DN 160 ISO-F/	DN 220 ICO F	DN 400 DN 40
DN 100 ISO-F	DN 150 PN 16	DN 150 PN 16	DN 320 ISO-F	DN 400 PN 10
DN 160 ISO-F	DN 250 ISO-F/	DN 250 ISO-F/	DN 320 ISO-F	DN 400 PN 10
DN 100 130-F	DN 250 PN 16	DN 250 PN 16	DN 320 130-F	DN 400 FN 10
P3	P3	P3	P3	P3
5 I	6.8 I	6.8 I	21 I	68 I
35 hPa	25 hPa	20 hPa	23 hPa	7 hPa
4500 min ⁻¹	4500 min ⁻¹	4500 min ⁻¹	2250 min ⁻¹	2250 min ⁻¹
1500 min ⁻¹	1500 min ⁻¹	1500 min ⁻¹	1200 min ⁻¹	1200 min ⁻¹
75 dB (A)	79 dB (A)	79 dB (A)	78 dB (A)	79 dB (A)
72 dB (A)	74 dB (A)	74 dB (A)	74 dB (A)	75 dB (A)
340 kg	640 kg	840 kg	1660 kg	3100 kg
290 kg	520 kg	715 kg	1480 kg	2800 kg
360 kg	655 kg	875 kg	-	-
Air	Air	Air	Air	Air
1 · 10 ⁻³ Pa m ³ /s	1 · 10 ⁻³ Pa m ³ /s	1 · 10 ⁻³ Pa m ³ /s	1 · 10 ⁻³ Pa m ³ /s	1 · 10 ⁻³ Pa m ³ /s
1 · 10 ⁻⁶ Pa m ³ /s	1 · 10 ⁻⁶ Pa m ³ /s	1 · 10 ⁻⁶ Pa m ³ /s	_	_
3TF	3TF	3TF	3TF	3TF
3000 min ⁻¹	3000 min ⁻¹	3000 min ⁻¹	1500 min ⁻¹	1500 min ⁻¹
3600 min ⁻¹	3600 min ⁻¹	3600 min ⁻¹	1800 min ⁻¹	1800 min ⁻¹
5.5 kW	11.0 kW	15.0 kW	22 kW	45 kW
6.3 kW	13.2 kW	18.5 kW	25 kW	52 kW
1075-3230 m ³ /h	2160-6490 m ³ /h	3240-9730 m ³ /h	3350-12550 m ³ /h	7310-27400 m ³ /h
2155 m ³ /h	4325 m ³ /h	6485 m ³ /h	8370 m ³ /h	18270 m ³ /h
2585 m ³ /h	5190 m ³ /h	7785 m³/h	10040 m ³ /h	21925 m ³ /h
230/400 V	400/690 V	400/690 V	400/690 V	400/690 V
265/460 V	460 V	460 V	460 V	460 V
IP 55				
5-40 °C				
PP W61 000	PP W71 000	PP W76 000	PP W80 000	PP W90 000
PP W61 001	PP W71 001	PP W76 001	PP W80 001	PP W90 001
PP W62 000	PP W72 000	PP W77 000		
PP 031 114 -X	PP 031 136 -X	PP 031 136 -X	PP 030 152 -X	PP 030 336 -T



Gas-circulation-cooled – OktaLine G

High differential pressures with lower power consumption

High pressure ranges and maximum differential pressures, in continuous operation up to 870 hPa, are ideal operating conditions for gas-circulation-cooled Roots pumps in the OktaLine G series.

At various power ratings from 5.5 kW up to a nominal rating of 200 kW, a pumping speed of 210 to 12,000 m³/h can be achieved. Gas-circulation-cooled Roots pumps can be operated without backing pumps.

Thanks to the frequency converter, energy use can be significantly reduced. Pumping speeds can be precisely adjusted. Gas-circulation-cooled Roots pumps are characterized by maximum reproducibility in process technologies and significantly lower operating costs compared to vacuum process pumps, such as injectors or liquid ring pumps.

Used as stand-alone pumps, they can be used in the pressure range from 130 to 1,013 hPa. Connecting two of these pumps in series enables the ultimate pressure to be reduced to 20 to 30 hPa. In combination with further Roots pumps the possible ultimate pressure can be reduced to the medium vacuum range. The motors and gas coolers needed for operation are both designed to meet process-specific requirements. In combination with Roots pumps it is possible in many cases to dispense with a pumping stage by using the OktaLine G, which saves money and significantly increases operating reliability. Other specific parts such as couplings, temperature sensors, spray equipment and base frames are available as optional components.

- Ample pumping speed range from 210 to 12,000 m³/h
- High pressure differences
- Flexibility and process adaptation, due to the motor power and frequency converter design.
- Thermal process gas line with OktaLine G and gas coolers
- Maintenance free, maximum reliability and highest uptime thanks to magnetic coupling (optional)



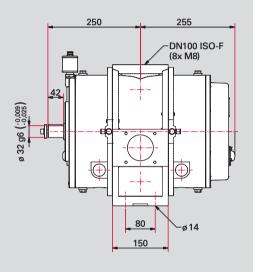
Applications

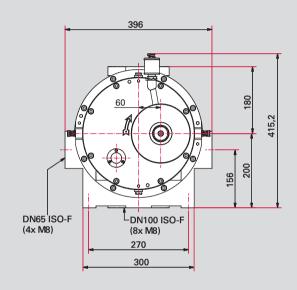
- Electron beam weldingVacuum furnaces
- Plasma research
- Particle accelerators
- Space simulationChemical and process technology

Gas-circulation-cooled – OktaLine G

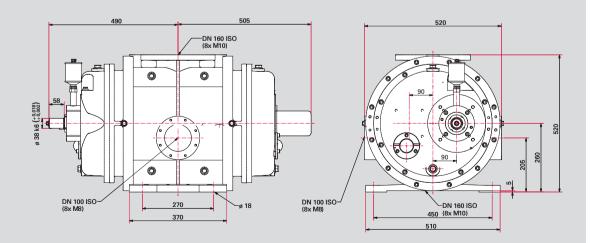
Dimensions

Okta 500 G

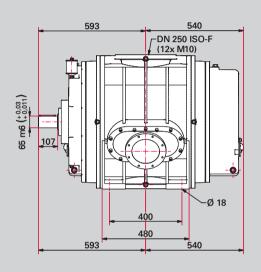


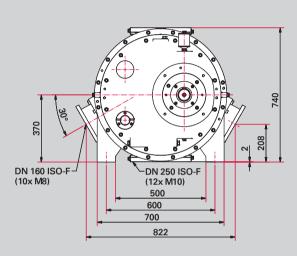


Okta 1500 G

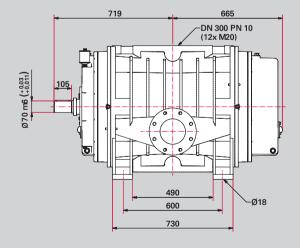


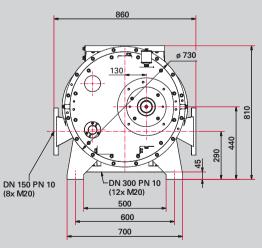
Okta 4000 G





Okta 8000 G



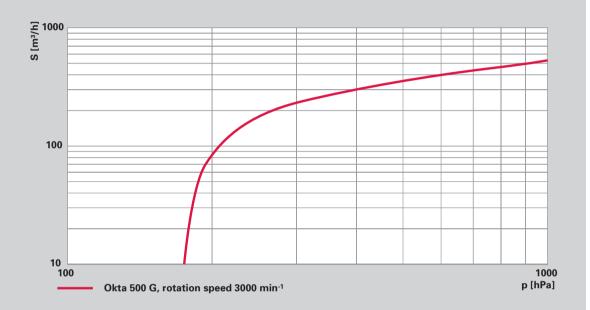




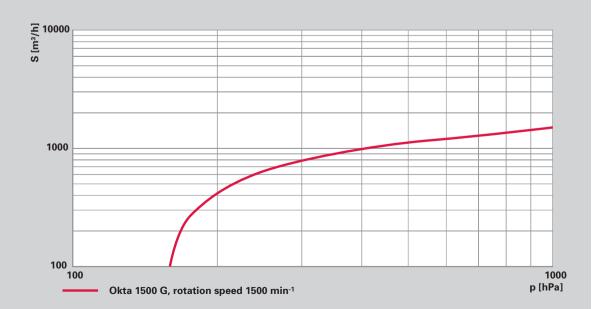
Gas-circulation-cooled – OktaLine G

Pumping speed

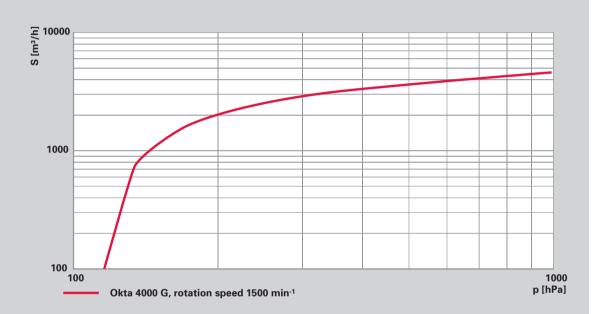
Okta 500 G



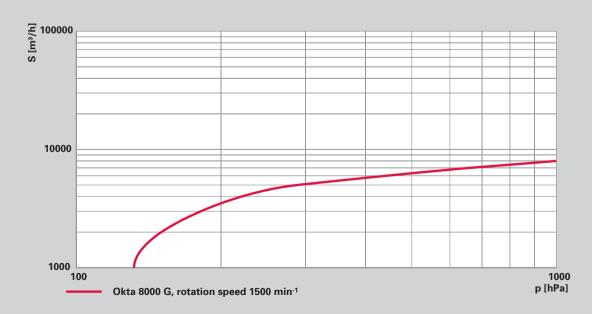
Okta 1500 G



Okta 4000 G



Okta 8000 G





Gas-circulation-cooled – OktaLine G

Technical data

Pump type	Okta 500 G	Okta 1500 G
Flange (out)	DN 100 ISO-F	DN 160 ISO-F
Flange (in)	DN 100 ISO-F	DN 160 ISO-F
Operating fluid ¹⁾	P3	P3
Operating fluid filling	3	71
Rotation speed	from 1200 to 3600 min ⁻¹	from 750 to 3600 min ⁻¹
Rotation speed max.	3600 min ⁻¹	3600 min ⁻¹
Rotation speed min.	1200 min ⁻¹	750 min ⁻¹
Ultimate pressure without gas ballast	130 hPa	130 hPa
Weight: without motor	125 kg	460 kg
Cooling method, standard	Gas-cooled	Gas-cooled
Cooling gas connection	DN 63 ISO-F	DN 100 ISO-F
Leak rate	1 · 10 ⁻³ Pa m ³ /s	1 · 10 ⁻³ Pa m ³ /s
Motor rating	max. 18.5 kW	max. 2 x 30 kW
Nominal rotation speed at 50 Hz	3000 min ⁻¹	1500 min ⁻¹
Nominal rotation speed at 60 Hz	3600 min ⁻¹	1800 min ⁻¹
Nominal pumping speed	210-630 m ³ /h	750-3600 m ³ /h
Nominal pumping speed at 50 Hz	520 m ³ /h	1500 m ³ /h
Nominal pumping speed at 60 Hz	630 m ³ /h	1800 m ³ /h
Noise level with connected exhaust line	75-105 dB (A)	75-105 dB (A)
Protection category	IP 55	IP 55
Sealing gas	Yes	Yes
Ambient temperature	5-40 °C	5-40 °C

Order number			
Okta G	PP G30 001	PP G50 001	

Accessories			
Splinter shield für Okta G	PP 030 149 AX	PP 031 114 -X	

¹⁾ Additional equipment and motor voltages available upon request.

Okta 4000 G	Okta 8000 G
DN 250 ISO-F	DN 300 PN 10
DN 250 ISO-F	DN 300 PN 10
P3	P3
21	21
from 750 to 2250 min ⁻¹	from 750 to 2250 min ⁻¹
2250 min ⁻¹	2250 min ⁻¹
750 min ⁻¹	750 min ⁻¹
130 hPa	130 hPa
1150 kg	1500 kg
Gas-cooled	Gas-cooled
DN 160 ISO-F	DN 150 PN 10
1 · 10 ⁻³ Pa m ³ /s	1 · 10 ⁻³ Pa m ³ /s
max. 132 kW	max. 200 kW
1500 min ⁻¹	1500 min ⁻¹
1800 min ⁻¹	1800 min ⁻¹
2300-6900 m ³ /h	4000-12000 m ³ /h
4600 m ³ /h	8000 m ³ /h
5500 m ³ /h	9600 m ³ /h
75-105 dB (A)	75-105 dB (A)
IP 55	IP 55
Yes	Yes
5-40 °C	5-40 °C
PP G70 001	PP G80 001
PP 031 136 -X	PP 070 315 -U



Explosion-protected – OktaLine ATEX

Magnetic coupled Roots pumps with ATEX certification for low and medium vacuum application. For processes that take place in explosive environments or for evacuating explosive gases we have developed ATEX certified pumps in accordance with directive 94/9/EC (ATEX 95), which meet the high requirements for explosion protection.

Our Roots pumps offer pumping speeds ranging from 280 to 5,190 m³/h. Depending on the application, you can choose between equipment category 2G or 3G. All pumps are suitable for temperature class T3.

The gear box and bearing area in our Roots pumps are separated from the gas pumping chamber. Because the rotors operate contactfree, dry operation is assured.

A further advantage: Due to convection cooling, operating costs are significantly lower than with water cooling. The pumps can be utilized universally. The design principle of our proven Roots pumps has also been expanded to include magnetic couplings. Thanks to these hermetically sealed pumps we achieve very low leak rates.

For the operation of the pumps, the terms of the operating instructions apply. We are pleased to provide you with the right solution for your application!

Customer benefits

- Explosion safety due to reliable construction and temperature monitoring – installation without additional flame arrester possible
- Pumps are hermetically sealed (leakrate < 10⁻⁶ Pa m³/s) risk of zone entrainment is minimized
- Pump can be operated without bypass (ATEX protection in case of passive rotation)
- Easiest on-site service even for the motor (can be changed on site thanks to standard ATEX IEC-motors)
- Flexible application due to variable differential pressure and rotational speed* – pump can start against atmospheric pressure
- Pressure surge resistance according to EN 1333, PN level 16

*when using a frequency converter

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Applications

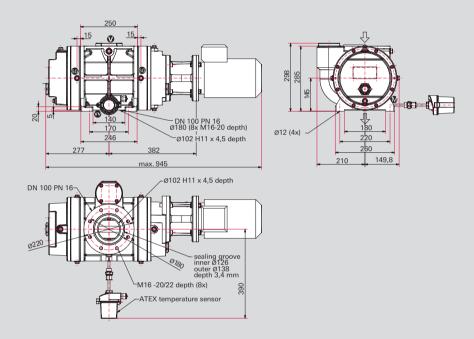
- Heat treatment
 Vacuum drying
 Vacuum furnaces
 Biotechnology
 Chemical and process technology



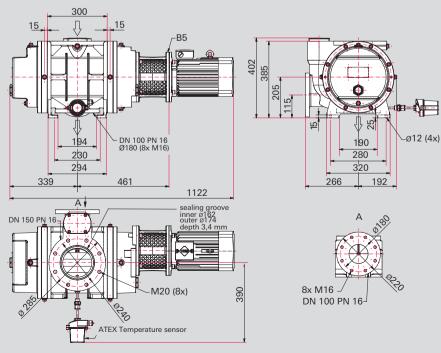
Explosion-protected – OktaLine ATEX

Dimensions

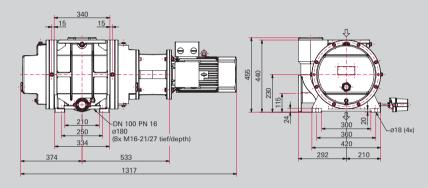
Okta 500 ATEX

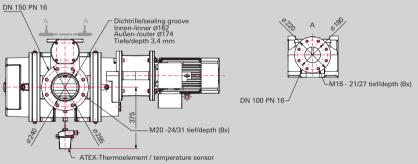


Okta 1000 ATEX

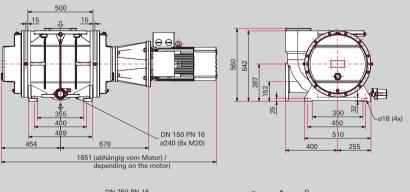


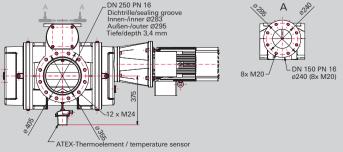
Okta 2000 ATEX





Okta 4000 ATEX



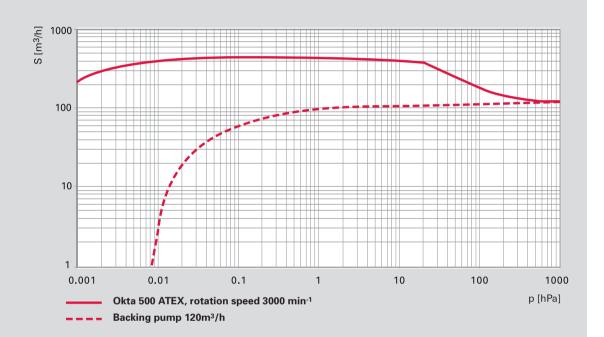




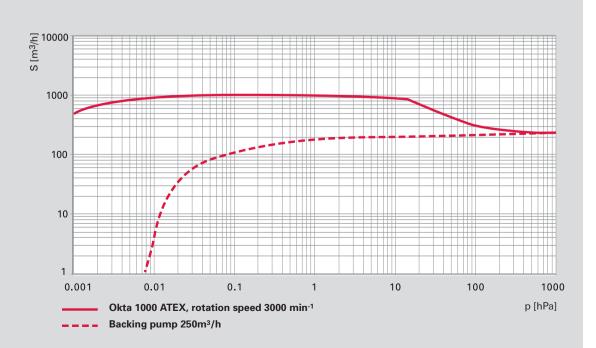
Explosion-protected – OktaLine ATEX

Pumping speed

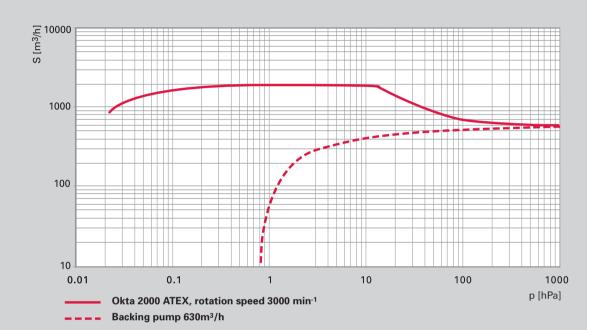
Okta 500 ATEX



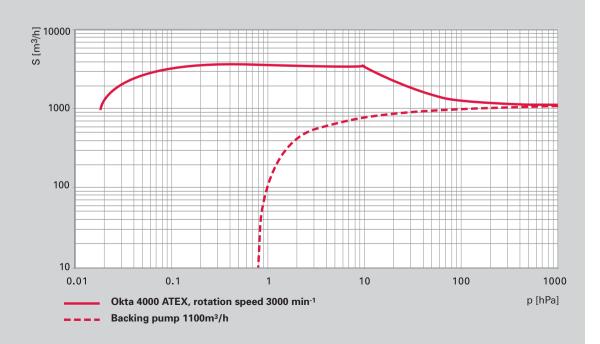
Okta 1000 ATEX



Okta 2000 ATEX



Okta 4000 ATEX



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Explosion-protected – OktaLine ATEX

Technical data

Pump type	Okta 500 ATEX	Okta 1000 ATEX
Flange (out)	DN 100 PN 16	DN 100 PN 16
Flange (in)	DN 100 PN 16	DN 150 PN 16
Version	ATEX with motor and magnetic coupling,	ATEX with motor and magnetic coupling,
Version	blocked overflow-valve	blocked overflow-valve
Equipment category	2G ²⁾ or 3G ³⁾	2G ²⁾ or 3G ³⁾
Operating fluid ¹⁾	P3	P3
Operating fluid filling	1.5 l	2.9
Rotation speed	from 1500 to 3600 min ⁻¹	from 1500 to 3600 min ⁻¹
Rotation speed max.	3600 min ⁻¹	3600 min ⁻¹
Rotation speed min.	1500 min ⁻¹	1500 min ⁻¹
Emission sound pressure level (EN ISO 2151) at intake pressure10 hPa	75 dB (A)	75 dB (A)
Emission sound pressure level (EN ISO 2151) at intake pressure1 hPa	70 dB (A)	72 dB (A)
Weight: with motor	154 kg	255 kg
Cooling method, standard	Air	Air
Leak rate	1 · 10 ⁻⁶ Pa m ³ /s	1 · 10 ⁻⁶ Pa m ³ /s
Motor protection	3TF	3TF
Nominal rotation speed at 50 Hz	3000 min ⁻¹	3000 min ⁻¹
Nominal rotation speed at 60 Hz	3600 min ⁻¹	3600 min ⁻¹
Rated power 50 Hz	1.5 kW	3.0 kW
Rated power 60 Hz	1.8 kW	3.5 kW
Nominal pumping speed	280-670 m ³ /h	590-1420 m ³ /h
Nominal pumping speed at 50 Hz	560 m ³ /h	1180 m ³ /h
Nominal pumping speed at 60 Hz	670 m ³ /h	1420 m ³ /h
Mains requirement: voltage 50 Hz	230/400 V	230/400 V
Mains requirement: voltage 60 Hz	265/460 V	265/460 V
Protection category	IP 55	IP 55
Ambient temperature	5-40 °C	5-40 °C

Order number			
Okta ATEX (3G ³⁾)	PP W33 300	PP W43 300	
Okta ATEX (2G ²⁾)	PP W33 400	PP W43 400	

¹⁾ Additional equipment and motor voltages available upon request.

 $^{^{2)}}$ According to ATEX directive 94/9/EC: II 2G IIB T3 X + 5 °C \leq Ta \leq +40 °C

 $^{^{3)}}$ According to ATEX directive 94/9/EC: II 3G IIB T3 X + 5 °C \leq Ta \leq +40 °C

Okta 2000 ATEX	Okta 4000 ATEX
DN 100 PN 16	DN 150 PN 16
DN 150 PN 16	DN 250 PN 16
ATEX with motor and magnetic coupling,	ATEX with motor and magnetic coupling,
blocked overflow-valve	blocked overflow-valve
2G ²⁾ or 3G ³⁾	2G ²⁾ or 3G ³⁾
P3	P3
5	71
from 1500 to 3600 min ⁻¹	from 1500 to 3600 min ⁻¹
3600 min ⁻¹	3600 min ⁻¹
1500 min ⁻¹	1500 min ⁻¹
75 dB (A)	79 dB (A)
72 dB (A)	74 dB (A)
390 kg	700 kg
Air	Air
1 · 10 ⁻⁶ Pa m ³ /s	1 · 10 ⁻⁶ Pa m ³ /s
3TF	3TF
3000 min ⁻¹	3000 min ⁻¹
3600 min ⁻¹	3600 min ⁻¹
5.5 kW	11 kW
6.3 kW	13 kW
1080-2585 m ³ /h	2160-5190 m ³ /h
2155 m ³ /h	4325 m ³ /h
2585 m ³ /h	5190 m ³ /h
230/400 V	230/400 V
265/460 V	265/460 V
IP 55	IP 55
5-40 °C	5-40 °C
PP W63 300	PP W73 300
PP W63 400	PP W73 400
11 4400 400	11 4470 400



Market segments and applications

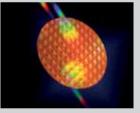
The Vacuum solution

Providing solutions means understanding the customer. One vacuum is not just like another vacuum, the key lies in the specific requirements. Which process should be used with which materials to produce the right results? Under which environmental conditions? Our customers demand sophisticated and intelligent results – and rightly so. Their vacuums have to deliver stability and low-maintenance pumps as well as reduced energy and resource consumption.

A complete vacuum solution covers all processes and steps involved in creating perfect vacuum conditions including consultation, products, accessories, application training programs and service. Our customers' requirements usually involve a high level of complexity. They not only include the precise vacuum requirements but also specific needs covering the entire system, the materials and products to be used and processed as well as process conditions. This is why we develop customized vacuum solutions hand in hand with our customers.





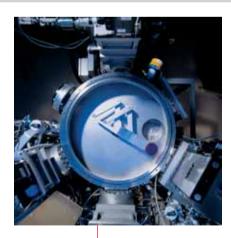






Semiconductor

Sputter system



- Extra long service intervals
- Low energy consumption of the vacuum pumps
- On-site service for all product lines from a single source















Market segments and applications

Industry

Leak detection



Customer benefits

- Detection of smallest leakages
- High reproducibility
- High throughput and fast cycle times
- Maximum environmental benefit
- On-site service for all product lines from a single source













Research & Development

Accelerator



- High reliability
- Special solution for accelerator applications
- Resistant to radioactive radiation
- Easy maintenance
- Highest quality and availibility
- On-site service for all product lines from a single source















Market segments and applications

Coating

Glass coating



Customer benefits

- Unmatched cost of ownership thanks to optimum pump design
- High availability due to robust design
- Largest product range in vacuum technology
- On-site service for all product lines from a single source













Analytics

Mass spectrometry



- Specially coordinated component selection
- Common interfaces and easy control
- Synchronization of vacuum generation and -measuring
- On-site service for all product lines from a single source









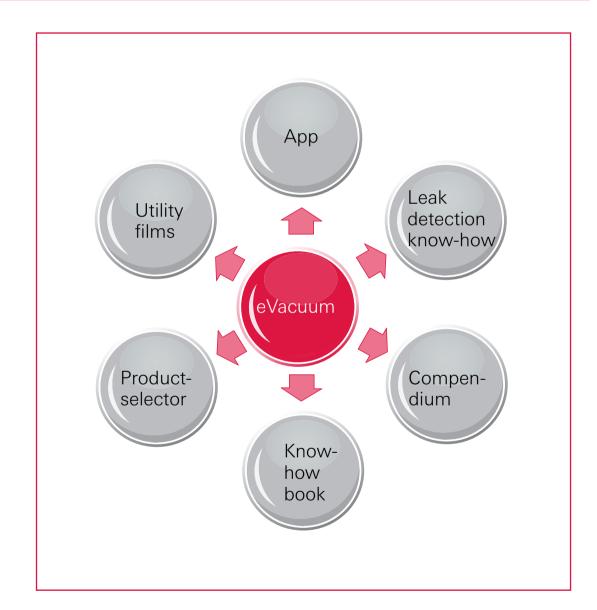






Market segments and applications

eVacuum



- Central point of contact for questions concerning vacuum technology for customers and employees
- Simple, comprehensive and interactive knowledge















Product overview





Product overview

Solutions

Consulting competence

Applications



Know-how



Experience



Customer intimacy

Products



Dimensioning



Engineering

eVacuum



Website



App

Service solutions

Worldwide quality



Representatives worldwide



Genuine parts



Training courses



Maintenance



...Austausch

Turbopumps

Hybrid bearing



Vacuum generation



HiPace Pumping speed 10 up to 2,000 l/s



ATH M/HiPace M Pumping speed 255 up to 2,800 l/s



Multi-stage

SplitFlow Pumping speed according to

Side

channel

pumps

Rotary vane pumps

Single-stage



UnoLine Plus Pumping speed 250 up to 500 m³/h



HenaLine Pumping speed 25 up to 1,000 m³/h



Pascal Pumping speed 5.4 up to 15 m³/h



Two-stage

PentaLine Pumping speed 22 up to 34 m³/h



DuoLine Pumping speed 1.25 up to 250 m³/h



Pascal Pumping speed 5.4 up to 60 m³/h

Diaphragm pumps



MVP Pumping speed

Screw pumps



HeptaDry Pumping speed 110 up to 525 m³/h



OnTool Booster



Product overview

Vacuum generation

Roots pumps

Air cooled



OktaLine Pumping speed 250 up to 25,000 m³/h

Gas cooled



OktaLine G Pumping speed 250 up to 12,000 m³/h

Explosionprotected



OktaLine ATEX Pumping speed 500 up to 4,000 m³/h

Multi-stage Roots pumps

Light duty



ACP 15-40



A 100 L Integrated load lock pump



ACP 120/ACG 600 annlication

Medium duty



A3P Serie Energy efficient process pump

Harsh duty



A3H Serie Harsh processes for semiconductor

Turbo pumping stations

Compact



HiCube Eco Pumping speed 35 up to 67 l/s

Standard



HiCube Classic Pumping speed 35 up to 685 l/s

High performance



HiCube Pro Pumping speed 35 up to 685 l/s,





CombiLine WU up to 2 · 10⁻³ hPa

With two-stage backing pump

Roots pumping stations



CombiLine WD Ultimate pressure up to 5 · 10⁻⁴ hPa

Vacuum analysis

Analysis equipment

With dry backing pump



CombiLine WH Ultimate pressure up to 2 · 10⁻³ hPa

Compact pumping station



LRS Pumping speed 150 up to 1,000 m³/h

pumping station



Pumping speed 150 up to 1,000 m³/h

Vacuum measurement

Measurement equipment

Analog



ActiveLine

Digital



DigiLine

Modular



ModulLine Total pressure measurement for R&D

Residual gas analysis



PrismaPlus Mass spectrometer Mass range 1-300 u

Gas analysis



HiQuad Mass spectrometer Mass range 1–2048 u



OmniStar Compact benchtop analysis system



High Pressure Analyzer Pressure range up to 50 hPa



SPM Sputter Process Monitor Pressure range up to 10 hPa



Product overview

Leak detection

Leak detectors

Portable



harsh environments



ASM 340 High performance all-rounder





High performance

ASM 380



ASM 182 T Robust industry standard



ASM 192 T devices



ASM 1002

test station



Modular

ASI 30 Industrial leak detection systems



Sniffing leak

detection

ASM 102 S Dry and portable

System technology

ASM 310

Mobile service use

Plant construction

Contamination Management Solutions



of contamination



ΔPR Removal of contamination



ADPC Detection of contamination

Multi-stage vacuum process



Vacu² processes

Components, valves, manipulators

Coating



Classic Coating systems

Helium leak detection systems



Complete systems

Helium-Recoveryunits



HRU systems

Vacuum components

Chambers

Standard Customized



TrinosLine

TrinosLine Customized for specific customer applications

Components



Hoses and flex connectors



ISO-KF, ISO-K, CF



Glass

elements

ISO-KF, ISO-K, ISO-F, CF

Customized elements



specific customer applications

Valves



Shut-off valves gas dosing valves

Feedthroughs

Current/voltage, fluids, insulators, combinations



Manipulators

X-, Y-, Z-motion, rotation, tilting



Pfeiffer Vacuum stands for innovative and custom vacuum solutions worldwide, technological perfection,

competent advice and reliable service.

Complete range of products

From a single component to complex systems: We are the only supplier of vacuum technology that provides a complete product portfolio.

Competence in theory and practice

Benefit from our know-how and our portfolio of training opportunities! We support you with your plant layout and provide first-class on-site service worldwide.

Are you looking for a perfect vacuum solution? Please contact us:

Pfeiffer Vacuum GmbH Headquarters · Germany T +49 6441 802-0 info@pfeiffer-vacuum.de